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**PATENT NUMBER and
ISSUE DATE**

U.S. UTILITY Patent Application

APPL NUM 10063128	FILING DATE 03/25/2002	CLASS 438	SUBCLASS 584	GAU 1783	EXAMINER A D M
**APPLICANTS: Liang Chao-Hu; Chen Chih-Hung; Tai Yu-Shan; Cheng Po-Lun;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no				ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no				NAUP0385USA	
Verified and Acknowledged Examiners's initials					
TITLE : Method of forming a polysilicon layer					
U.S. DEPT. OF COMM./PAT. & TM.-PTO-4361 (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims <input type="checkbox"/> Print Claim for O.G. <input type="checkbox"/>
ISSUE FEE		Primary Examiner	DRAWING
Amount Due	Date Paid		Sheets Drwg. <input type="checkbox"/> Figs. Drwg. <input type="checkbox"/> Print Fig. <input type="checkbox"/>
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Applicati n Examiner
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